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# U.S. UTILITY Patent Application

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CLASS  
438

SUBCLASS  
779

ART UNIT  
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EXAMINER  
Sarkar

APPLICANTS  
TITLE

Rao Annaprasada

Method of improving adhesion of cap oxide to nanoporous silica for integrated circuit fabrication

PTO-2040  
12/99

☐ The term of this patent

☐ The terminal \_\_\_\_\_ months of this patent have been disclaimed.

(Primary Examiner)

(Act)

(Legal Instruments Examiner)

(Act)

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